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RECEIVED

Re: U.S. Patent Application No. 09/801,060
Samsung Electronics Co., Ltd.

OCT 31 2003

Technology Center 2600

Dear Mr. Mexic:

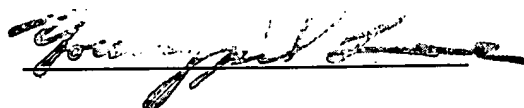
In connection with the above-identified application, please be informed that five references were cited in the Search Report dated 27 June 2003 of the European Patent Application No. 01301730.6 which corresponds to the above U.S. application. Thus, we enclose herewith copies of the search report together with copies of the cited references.

To meet the duty of disclosure, please take the necessary steps for submitting an Information Disclosure Statement in due course.

We appreciate your cooperation in this case.

Sincerely yours,

Y.P. LEE, MOCK & PARTNERS


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YPL/jja
Enclosure